

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaki KATO et al.

Group Art Unit: 2851

Application No.: 09/828,914

Examiner: H. Nguyen

Filed: April 10, 2001

Docket No.: 109187

EXPOSURE APPARATUS, METHOD FOR MANUFACTURING THEREOF,

AND METHOD FOR MANUFACTURING MICRODEVICE

REQUEST FOR APPROVAL OF DRAWING CORRECTIONS

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

The Examiner is requested to review and approve the proposed corrections to Figure 1, marked in red on the attached copy of such drawing figure.

Upon approval by the Examiner, and upon allowance of this application, the formal drawing will be corrected.

Respectfully submitted

Mario A. Costantino Registration No. 33,565

MAC/ccs

Date: March 26, 2003

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